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# ***Nanoscale and Quantum Materials: From Synthesis and Laser Processing to Applications 2025***

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**25–27 January 2025**  
**San Francisco, California, United States**

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*Published by*  
SPIE

**Volume 13352**

Proceedings of SPIE 0277-786X, V. 13352

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Author(s), "Title of Paper," in *Nanoscale and Quantum Materials: From Synthesis and Laser Processing to Applications 2025*, edited by Andrei V. Kabashin, Maria Farsari, Masoud Mahjouri-Samani, Proc. of SPIE 13352, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510684522

ISBN: 9781510684539 (electronic)

Published by

**SPIE**

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time)

[SPIE.org](http://SPIE.org)

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